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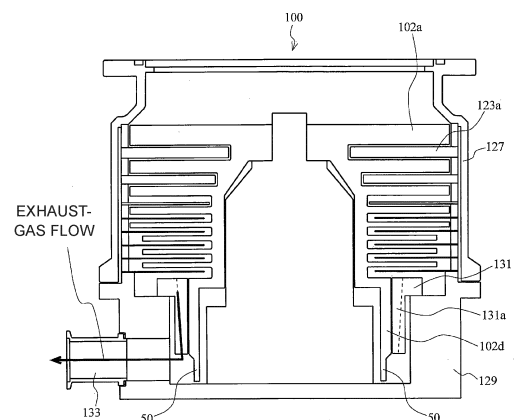
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(54) **VACUUM PUMP AND ROTARY CYLINDRICAL BODY PROVIDED TO VACUUM PUMP**

(57) A vacuum pump that is capable of reducing stress without lowering a rotation speed of a rotating cylinder (rotating body) and also improves exhaust performance, and a rotating cylinder provided in the vacuum pump are provided. A lower portion of a cylindrical portion (rotating cylinder) provided in a vacuum pump on the outlet port side has an extension portion extending to a further downstream side than a stationary part of a thread groove exhaust element. In the extension portion, the smaller the outer diameter, the smaller the stress applied to the inner diameter side during rotation. As such, the configuration including a reduced diameter portion reduces the stress applied to the inner diameter side of the cylindrical portion without lowering the rotation speed of the rotating body (such as the cylindrical portion). Additionally, providing a gradually decreasing diameter structure in the extension portion reduces stress concentration at the reduced diameter portion.

Fig. 5



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**Description**

## TECHNICAL FIELD

**[0001]** The present invention relates to a vacuum pump and a rotating cylinder provided in the vacuum pump, and more particularly to a vacuum pump that reduces stress applied to a rotating cylinder and a rotating cylinder provided in the vacuum pump.

## BACKGROUND ART

**[0002]** Some vacuum pumps installed in vacuum chambers to perform vacuum exhaust processing have rotating bodies and thread groove exhaust elements (thread groove type exhaust mechanisms/thread groove pump portions). A vacuum pump equipped with such a thread groove exhaust element has a rotating cylinder (rotor cylindrical portion), which does not have rotor blades, under a portion of the rotating body having rotor blades, with the rotating cylinder being configured to compress gas in the thread groove exhaust element.

**[0003]** In vacuum pumps that include vacuum pumps having such rotor cylindrical portions, centrifugal force typically applies stress to inner diameter sides of the rotor cylindrical portions, and this stress may exceed the design standard value.

**[0004]** FIG. 9 is a diagram illustrating a conventional turbomolecular pump 100.

**[0005]** As shown in FIG. 9, in the conventional turbomolecular pump 100, a cylindrical portion 102d is placed facing a threaded spacer 131 in the axial direction across a clearance. When stress is applied to the cylindrical portion 102d, long-term operation at high temperatures causes the cylindrical portion 102d to experience creep and gradually deform and/or expand.

**[0006]** A creep life, which is a period before a specified value of the clearance between the threaded spacer 131 and the cylindrical portion 102d becomes small due to a creep phenomenon, is preferably long as much as possible from the viewpoint of maintenance costs.

## CITATION LIST

## PATENT LITERATURE

**[0007]** [PTL 1] Japanese Patent Application Publication No. H10-246197

**[0008]** PTL 1 describes a technique for preventing local stress or temperature rise in rotor blades and portions supporting the rotor blades even during high-speed rotation. In this technique, an outer diameter of a rotor blade on the outlet port side differs from an outer diameter of a rotor blade on the inlet port side.

## SUMMARY OF INVENTION

## TECHNICAL PROBLEM

**[0009]** Other than the configuration as described in PTL 1, a technique has been used that lowers a rotation speed of the rotating body (rotor blades/rotating cylinder) to reduce stress.

**[0010]** However, a lower rotation speed of the rotating body results in decreased exhaust performance.

**[0011]** It is an object of the present invention to provide a vacuum pump that is capable of reducing stress without lowering a rotation speed of a rotating cylinder (rotating body) and also improves exhaust performance, and a rotating cylinder provided in the vacuum pump.

## SOLUTION TO PROBLEM

**[0012]** The present invention according to claim 1 provides a vacuum pump including: a casing having an inlet port and an outlet port; a thread groove type exhaust mechanism that is fixed to the casing and includes a thread groove; a rotating shaft that is enclosed and rotationally supported by the casing; and a rotating cylinder disposed on the rotating shaft, the rotating cylinder including an opposed portion facing the thread groove type exhaust mechanism across a clearance and an extension portion extending to a further downstream side than the thread groove type exhaust mechanism, the extension portion including a reduced diameter portion having an outer diameter that is smaller than an outer diameter of the opposed portion and a gradually decreasing diameter structure configured to reduce stress concentration.

**[0013]** The present invention according to claim 2 provides the vacuum pump according to claim 1, wherein the gradually decreasing diameter structure is a tapered structure.

**[0014]** The present invention according to claim 3 provides the vacuum pump according to claim 1, wherein the gradually decreasing diameter structure is a curved shape.

**[0015]** The present invention according to claim 4 provides the vacuum pump according to any one of claims 1 to 3, wherein the gradually decreasing diameter structure is included in the reduced diameter portion.

**[0016]** The present invention according to claim 5 provides a rotating cylinder of a vacuum pump, wherein the vacuum pump includes: a casing having an inlet port and an outlet port; a thread groove type exhaust mechanism that is fixed to the casing and includes a thread groove; and a rotating shaft that is enclosed and rotationally supported by the casing, the rotating cylinder comprises a rotating cylinder disposed on the rotating shaft, the rotating cylinder is disposed on the rotating shaft, the rotating cylinder includes an opposed portion facing the thread groove type exhaust mechanism across a clearance and an extension portion extending to a further downstream side than the thread groove type exhaust

mechanism, the extension portion including a reduced diameter portion having an outer diameter that is smaller than an outer diameter of the opposed portion and a gradually decreasing diameter structure configured to reduce stress concentration.

#### ADVANTAGEOUS EFFECTS OF INVENTION

**[0017]** According to the present invention, the stress in the portion of the rotating cylinder that accounts for the creep life is reduced. Accordingly, the exhaust performance is maintained or improved as compared to a configuration that is designed to lower the rotation speed in order to reduce the stress.

#### BRIEF DESCRIPTION OF DRAWINGS

##### **[0018]**

FIG. 1 is a schematic diagram showing an example of the configuration of a turbomolecular pump of an embodiment according to the present invention;  
 FIG. 2 is a circuit diagram of an amplifier circuit used in an embodiment of the present invention;  
 FIG. 3 is a time chart showing control performed when a current command value is greater than a detected value in an embodiment of the present invention;  
 FIG. 4 is a time chart showing control performed when a current command value is less than a detected value in an embodiment of the present invention;  
 FIG. 5 is a schematic diagram showing an example of the configuration of a turbomolecular pump according to a first embodiment of the present invention;  
 FIG. 6 is a diagram illustrating a cylindrical portion and an extension portion of the turbomolecular pump according to the first embodiment of the present invention;  
 FIG. 7 is an enlarged view of the cylindrical portion and the extension portion shown in FIG. 6;  
 FIGS. 8A and 8B are diagrams illustrating the shape of the extension portion; and  
 FIG. 9 is a schematic view showing an example of the configuration of a conventional turbomolecular pump.

#### DESCRIPTION OF EMBODIMENTS

##### (i) Outline of Embodiments

**[0019]** In the turbomolecular pump (vacuum pump) according to an embodiment of the present invention, the lower portion of the cylindrical portion (rotating cylinder) of the turbomolecular pump on the outlet port side has an extension portion extending to a further downstream side than the stationary part of the thread groove exhaust

element. The extension portion includes a reduced diameter portion.

**[0020]** More specifically, the lower end portion (outlet port side end portion) of the cylindrical portion is designed to be longer than the thread groove exhaust element to form the extension portion. The extension portion of the rotor cylindrical portion has the reduced diameter portion having a smaller outer diameter than the portion that is located on the inlet port side of the rotor cylindrical portion and faces the thread groove exhaust element (opposed portion). Additionally, the extension portion has a gradually decreasing diameter structure. This gradually decreasing diameter structure refers to a structure having a diameter that gradually decreases.

**[0021]** In the extension portion, the smaller the outer diameter, the smaller the stress applied to the inner diameter side during rotation. As such, the configuration including the reduced diameter portion and the gradually decreasing diameter structure described above reduces the stress applied to the inner diameter side of the cylindrical portion without lowering the rotation speed of the rotating body (such as the cylindrical portion).

##### (ii) Details of Embodiments

**[0022]** Referring to FIGS. 1 to 8B, preferred embodiments of the present invention are now described in detail.

**[0023]** FIG. 1 is a vertical cross-sectional view of the turbomolecular pump 100. As shown in FIG. 1, the turbomolecular pump 100 has a circular outer cylinder 127 having an inlet port 101 at its upper end. A rotating body 103 in the outer cylinder 127 includes a plurality of rotor blades 102 (102a, 102b, 102c, ...), which are turbine blades for gas suction and exhaustion, in its outer circumference section. The rotor blades 102 extend radially in multiple stages. The rotating body 103 has a rotor shaft 113 in its center. The rotor shaft 113 is suspended in the air and position-controlled by a magnetic bearing of 5-axis control, for example.

**[0024]** Upper radial electromagnets 104 include four electromagnets arranged in pairs on an X-axis and a Y-axis. Four upper radial sensors 107 are provided in close proximity to the upper radial electromagnets 104 and associated with the respective upper radial electromagnets 104. Each upper radial sensor 107 may be an inductance sensor or an eddy current sensor having a conduction winding, for example, and detects the position of the rotor shaft 113 based on a change in the inductance of the conduction winding, which changes according to the position of the rotor shaft 113. The upper radial sensors 107 are configured to detect a radial displacement of the rotor shaft 113, that is, the rotating body 103 fixed to the rotor shaft 113, and send it to the controller 200.

**[0025]** In the controller 200, for example, a compensation circuit having a PID adjustment function generates an excitation control command signal for the upper radial electromagnets 104 based on a position signal detected

by the upper radial sensors 107. Based on this excitation control command signal, an amplifier circuit 150 (described below) shown in FIG. 2 controls and excites the upper radial electromagnets 104 to adjust a radial position of an upper part of the rotor shaft 113.

**[0026]** The rotor shaft 113 may be made of a high magnetic permeability material (such as iron and stainless steel) and is configured to be attracted by magnetic forces of the upper radial electromagnets 104. The adjustment is performed independently in the X-axis direction and the Y-axis direction. Lower radial electromagnets 105 and lower radial sensors 108 are arranged in a similar manner as the upper radial electromagnets 104 and the upper radial sensors 107 to adjust the radial position of the lower part of the rotor shaft 113 in a similar manner as the radial position of the upper part.

**[0027]** Additionally, axial electromagnets 106A and 106B are arranged so as to vertically sandwich a metal disc 111, which has a shape of a circular disc and is provided in the lower part of the rotor shaft 113. The metal disc 111 is made of a high magnetic permeability material such as iron. An axial sensor 109 is provided to detect an axial displacement of the rotor shaft 113 and send an axial position signal to the controller 200.

**[0028]** In the controller 200, the compensation circuit having the PID adjustment function may generate an excitation control command signal for each of the axial electromagnets 106A and 106B based on the signal on the axial position detected by the axial sensor 109. Based on these excitation control command signals, the amplifier circuit 150 controls and excites the axial electromagnets 106A and 106B separately so that the axial electromagnet 106A magnetically attracts the metal disc 111 upward and the axial electromagnet 106B attracts the metal disc 111 downward. The axial position of the rotor shaft 113 is thus adjusted.

**[0029]** As described above, the controller 200 appropriately adjusts the magnetic forces exerted by the axial electromagnets 106A and 106B on the metal disc 111, magnetically levitates the rotor shaft 113 in the axial direction, and suspends the rotor shaft 113 in the air in a non-contact manner. The amplifier circuit 150, which controls and excites the upper radial electromagnets 104, the lower radial electromagnets 105, and the axial electromagnets 106A and 106B, is described below.

**[0030]** The motor 121 includes a plurality of magnetic poles circumferentially arranged to surround the rotor shaft 113. Each magnetic pole is controlled by the controller 200 so as to drive and rotate the rotor shaft 113 via an electromagnetic force acting between the magnetic pole and the rotor shaft 113. The motor 121 also includes a rotational speed sensor (not shown), such as a Hall element, a resolver, or an encoder, and the rotational speed of the rotor shaft 113 is detected based on a detection signal of the rotational speed sensor.

**[0031]** Furthermore, a phase sensor (not shown) is attached adjacent to the lower radial sensors 108 to detect the phase of rotation of the rotor shaft 113. The controller

200 detects the position of the magnetic poles using both detection signals of the phase sensor and the rotational speed sensor.

**[0032]** A plurality of stator blades 123 (123a, 123b, 123c, ...) are arranged slightly spaced apart from the rotor blades 102 (102a, 102b, 102c, ...). Each rotor blade 102 (102a, 102b, 102c, ...) is inclined by a predetermined angle from a plane perpendicular to the axis of the rotor shaft 113 in order to transfer exhaust gas molecules downward through collision.

**[0033]** The stator blades 123 are also inclined by a predetermined angle from a plane perpendicular to the axis of the rotor shaft 113. The stator blades 123 extend inward of the outer cylinder 127 and alternate with the stages of the rotor blades 102. The outer circumference ends of the stator blades 123 are inserted between and thus supported by a plurality of layered stator blade spacers 125 (125a, 125b, 125c, ...).

**[0034]** The stator blade spacers 125 are ring-shaped members made of a metal, such as aluminum, iron, stainless steel, or copper, or an alloy containing these metals as components, for example. The outer cylinder 127 is fixed to the outer circumferences of the stator blade spacers 125 with a slight gap. A base portion 129 is located at the base of the outer cylinder 127. The base portion 129 has an outlet port 133 providing communication to the outside. The exhaust gas transferred to the base portion 129 through the inlet port 101 from the chamber is then sent to the outlet port 133.

**[0035]** According to the application of the turbomolecular pump 100, a threaded spacer 131 may be provided between the lower part of the stator blade spacer 125 and the base portion 129. The threaded spacer 131 is a cylindrical member made of a metal such as aluminum, copper, stainless steel, or iron, or an alloy containing these metals as components. The threaded spacer 131 has a plurality of helical thread grooves 131a in its inner circumference surface. When exhaust gas molecules move in the rotation direction of the rotating body 103, these molecules are transferred toward the outlet port 133 in the direction of the helix of the thread grooves 131a. In the lowermost section of the rotating body 103 below the rotor blades 102 (102a, 102b, 102c, ...), a cylindrical portion 102d extends downward. The outer circumference surface of the cylindrical portion 102d is cylindrical and projects toward the inner circumference surface of the threaded spacer 131. The outer circumference surface is adjacent to but separated from the inner circumference surface of the threaded spacer 131 by a predetermined gap. The exhaust gas transferred to the thread grooves 131a by the rotor blades 102 and the stator blades 123 is guided by the thread grooves 131a to the base portion 129.

**[0036]** The base portion 129 is a disc-shaped member forming the base section of the turbomolecular pump 100, and is generally made of a metal such as iron, aluminum, or stainless steel. The base portion 129 physically holds the turbomolecular pump 100 and also serves

as a heat conduction path. As such, the base portion 129 is preferably made of rigid metal with high thermal conductivity, such as iron, aluminum, or copper.

**[0037]** In this configuration, when the motor 121 drives and rotates the rotor blades 102 together with the rotor shaft 113, the interaction between the rotor blades 102 and the stator blades 123 causes the suction of exhaust gas from the chamber through the inlet port 101. The exhaust gas taken through the inlet port 101 moves between the rotor blades 102 and the stator blades 123 and is transferred to the base portion 129. At this time, factors such as the friction heat generated when the exhaust gas comes into contact with the rotor blades 102 and the conduction of heat generated by the motor 121 increase the temperature of the rotor blades 102. This heat is conducted to the stator blades 123 through radiation or conduction via gas molecules of the exhaust gas, for example.

**[0038]** The stator blade spacers 125 are joined to each other at the outer circumference portion and conduct the heat received by the stator blades 123 from the rotor blades 102, the friction heat generated when the exhaust gas comes into contact with the stator blades 123, and the like to the outside.

**[0039]** In the above description, the threaded spacer 131 is provided at the outer circumference of the cylindrical portion 102d of the rotating body 103, and the thread grooves 131a are engraved in the inner circumference surface of the threaded spacer 131. However, this may be inversed in some cases, and a thread groove may be engraved in the outer circumference surface of the cylindrical portion 102d, while a spacer having a cylindrical inner circumference surface may be arranged around the outer circumference surface.

**[0040]** According to the application of the turbomolecular pump 100, to prevent the gas drawn through the inlet port 101 from entering an electrical portion, which includes the upper radial electromagnets 104, the upper radial sensors 107, the motor 121, the lower radial electromagnets 105, the lower radial sensors 108, the axial electromagnets 106A, 106B, and the axial sensor 109, the electrical portion may be surrounded by a stator column 122. The inside of the stator column 122 may be maintained at a predetermined pressure by purge gas.

**[0041]** In this case, the base portion 129 has a pipe (not shown) through which the purge gas is introduced. The introduced purge gas is sent to the outlet port 133 through gaps between a protective bearing 120 and the rotor shaft 113, between the rotor and the stator of the motor 121, and between the stator column 122 and the inner circumference cylindrical portion of the rotor blade 102.

**[0042]** The turbomolecular pump 100 requires the identification of the model and control based on individually adjusted unique parameters (for example, various characteristics associated with the model). To store these control parameters, the turbomolecular pump 100 includes an electronic circuit portion 141 in its main body.

The electronic circuit portion 141 may include a semiconductor memory, such as an EEPROM, electronic components such as semiconductor elements for accessing the semiconductor memory, and a substrate 143 for mounting these components. The electronic circuit portion 141 is housed under a rotational speed sensor (not shown) near the center, for example, of the base portion 129, which forms the lower part of the turbomolecular pump 100, and is closed by an airtight bottom lid 145.

**[0043]** Some process gas introduced into the chamber in the manufacturing process of semiconductors has the property of becoming solid when its pressure becomes higher than a predetermined value or its temperature becomes lower than a predetermined value. In the turbomolecular pump 100, the pressure of the exhaust gas is lowest at the inlet port 101 and highest at the outlet port 133. When the pressure of the process gas increases beyond a predetermined value or its temperature decreases below a predetermined value while the process gas is being transferred from the inlet port 101 to the outlet port 133, the process gas is solidified and adheres and accumulates on the inner side of the turbomolecular pump 100.

**[0044]** For example, when  $\text{SiCl}_4$  is used as the process gas in an Al etching apparatus, according to the vapor pressure curve, a solid product (for example,  $\text{AlCl}_3$ ) is deposited at a low vacuum (760 [torr] to  $10^{-2}$  [torr]) and a low temperature (about 20 [°C]) and adheres and accumulates on the inner side of the turbomolecular pump 100. When the deposit of the process gas accumulates in the turbomolecular pump 100, the accumulation may narrow the pump flow passage and degrade the performance of the turbomolecular pump 100. The above-mentioned product tends to solidify and adhere in areas with higher pressures, such as the vicinity of the outlet port 133 and the vicinity of the threaded spacer 131.

**[0045]** To solve this problem, conventionally, a heater or annular water-cooled tube 149 (not shown) is wound around the outer circumference of the base portion 129, and a temperature sensor (e.g., a thermistor, not shown) is embedded in the base portion 129, for example. The signal of this temperature sensor is used to perform control to maintain the temperature of the base portion 129 at a constant high temperature (preset temperature) by heating with the heater or cooling with the water-cooled tube 149 (hereinafter referred to as TMS (temperature management system)).

**[0046]** The amplifier circuit 150 is now described that controls and excites the upper radial electromagnets 104, the lower radial electromagnets 105, and the axial electromagnets 106A and 106B of the turbomolecular pump 100 configured as described above. FIG. 2 is a circuit diagram of the amplifier circuit 150.

**[0047]** In FIG. 2, one end of an electromagnet winding 151 forming an upper radial electromagnet 104 or the like is connected to a positive electrode 171a of a power supply 171 via a transistor 161, and the other end is connected to a negative electrode 171b of the power supply

171 via a current detection circuit 181 and a transistor 162. Each transistor 161, 162 is a power MOSFET and has a structure in which a diode is connected between the source and the drain thereof.

**[0048]** In the transistor 161, a cathode terminal 161a of its diode is connected to the positive electrode 171a, and an anode terminal 161b is connected to one end of the electromagnet winding 151. In the transistor 162, a cathode terminal 162a of its diode is connected to a current detection circuit 181, and an anode terminal 162b is connected to the negative electrode 171b.

**[0049]** A diode 165 for current regeneration has a cathode terminal 165a connected to one end of the electromagnet winding 151 and an anode terminal 165b connected to the negative electrode 171b. Similarly, a diode 166 for current regeneration has a cathode terminal 166a connected to the positive electrode 171a and an anode terminal 166b connected to the other end of the electromagnet winding 151 via the current detection circuit 181. The current detection circuit 181 may include a Hall current sensor or an electric resistance element, for example.

**[0050]** The amplifier circuit 150 configured as described above corresponds to one electromagnet. Accordingly, when the magnetic bearing uses 5-axis control and has ten electromagnets 104, 105, 106A, and 106B in total, an identical amplifier circuit 150 is configured for each of the electromagnets. These ten amplifier circuits 150 are connected to the power supply 171 in parallel.

**[0051]** An amplifier control circuit 191 may be formed by a digital signal processor portion (not shown, hereinafter referred to as a DSP portion) of the controller 200. The amplifier control circuit 191 switches the transistors 161 and 162 between on and off.

**[0052]** The amplifier control circuit 191 is configured to compare a current value detected by the current detection circuit 181 (a signal reflecting this current value is referred to as a current detection signal 191c) with a predetermined current command value. The result of this comparison is used to determine the magnitude of the pulse width (pulse width time Tp1, Tp2) generated in a control cycle Ts, which is one cycle in PWM control. As a result, gate drive signals 191a and 191b having this pulse width are output from the amplifier control circuit 191 to gate terminals of the transistors 161 and 162.

**[0053]** Under certain circumstances such as when the rotational speed of the rotating body 103 reaches a resonance point during acceleration, or when a disturbance occurs during a constant speed operation, the rotating body 103 may require positional control at high speed and with a strong force. For this purpose, a high voltage of about 50 V, for example, is used for the power supply 171 to enable a rapid increase (or decrease) in the current flowing through the electromagnet winding 151. Additionally, a capacitor is generally connected between the positive electrode 171a and the negative electrode 171b of the power supply 171 to stabilize the power supply 171 (not shown).

**[0054]** In this configuration, when both transistors 161 and 162 are turned on, the current flowing through the electromagnet winding 151 (hereinafter referred to as an electromagnet current  $i_L$ ) increases, and when both are turned off, the electromagnet current  $i_L$  decreases.

**[0055]** Also, when one of the transistors 161 and 162 is turned on and the other is turned off, a freewheeling current is maintained. Passing the freewheeling current through the amplifier circuit 150 in this manner reduces the hysteresis loss in the amplifier circuit 150, thereby limiting the power consumption of the entire circuit to a low level. Moreover, by controlling the transistors 161 and 162 as described above, high frequency noise, such as harmonics, generated in the turbomolecular pump 100 can be reduced. Furthermore, by measuring this freewheeling current with the current detection circuit 181, the electromagnet current  $i_L$  flowing through the electromagnet winding 151 can be detected.

**[0056]** That is, when the detected current value is smaller than the current command value, as shown in FIG. 3, the transistors 161 and 162 are simultaneously on only once in the control cycle Ts (for example, 100  $\mu$ s) for the time corresponding to the pulse width time Tp1. During this time, the electromagnet current  $i_L$  increases accordingly toward the current value  $i_{Lmax}$  (not shown) that can be passed from the positive electrode 171a to the negative electrode 171b via the transistors 161 and 162.

**[0057]** When the detected current value is larger than the current command value, as shown in FIG. 4, the transistors 161 and 162 are simultaneously off only once in the control cycle Ts for the time corresponding to the pulse width time Tp2. During this time, the electromagnet current  $i_L$  decreases accordingly toward the current value  $i_{Lmin}$  (not shown) that can be regenerated from the negative electrode 171b to the positive electrode 171a via the diodes 165 and 166.

**[0058]** In either case, after the pulse width time Tp1, Tp2 has elapsed, one of the transistors 161 and 162 is on. During this period, the freewheeling current is thus maintained in the amplifier circuit 150.

**[0059]** FIG. 5 is a diagram illustrating the outline of a turbomolecular pump 100 according to the first embodiment.

**[0060]** FIG. 6 is a diagram illustrating an opposed portion 10t and an extension portion 11 (a gradually decreasing diameter structure 11a and a reduced diameter portion 50) of a cylindrical portion 102d of the turbomolecular pump 100 shown in FIG. 5.

**[0061]** FIG. 7 is an enlarged view of the opposed portion 10t, the extension portion 11, the gradually decreasing diameter structure 11a, and the reduced diameter portion 50 in the cylindrical portion 102d.

**[0062]** As shown in FIGS. 5 to 7, the cylindrical portion 102d includes the opposed portion 10t, which faces the threaded spacer 131 in the axial direction with a predetermined clearance therebetween, the extension portion 11, which extends toward the outlet port 133 beyond the

threaded spacer 131, the gradually decreasing diameter structure 11a, and the reduced diameter portion 50. The shape of the reduced diameter portion 50 is cylindrical as with the cylindrical portion 102d.

**[0063]** As is clear from FIG. 6, the extension portion 11 consists of the gradually decreasing diameter structure 11a and the reduced diameter portion 50.

**[0064]** In the present embodiment, "r" denotes the inner diameter of the opposed portion 10t of the cylindrical portion 102d, and "Rt" denotes its outer diameter.

**[0065]** Additionally, as shown in FIG. 7, "Rs" denotes the outer diameter of the lower end (the end closer to the outlet port 133) of the gradually decreasing diameter structure 11a and the reduced diameter portion 50, and "m" denotes the gradually changing outer diameter of the gradually decreasing diameter structure 11a. As used in this embodiment, the "gradually changing outer diameter" refers to an "outer diameter that gradually changes".

**[0066]** In the cylindrical portion 102d of the turbomolecular pump 100 according to the present embodiment, the extension portion 11, which extends toward the outlet port 133 beyond the threaded spacer 131, has the gradually decreasing diameter structure 11a, which has the gradually changing outer diameter m that is smaller than the outer diameter Rt of the portion of the cylindrical portion 102d (the opposed portion 10t) other than the extension portion 11. In the embodiment shown in FIGS. 5 to 7, the gradually changing outer diameter m gradually decreases in value from the inlet port side to the outlet port side (that is, the outer diameter gradually changes).

**[0067]** In other words, the cylindrical portion 102d according to the present embodiment has a portion having a gradient of a predetermined angle  $\theta$  (gradually decreasing diameter structure 11a) on the outer diameter side of the extension portion 11. This gradient may be formed, for example, by tapering the outer diameter side of the extension portion 11.

**[0068]** The present embodiment has the configuration in which the starting point (point of origin) of the extension portion 11 coincides with the starting point of the gradually decreasing diameter structure 11a. However, the present invention is not limited to this. That is, in the extension portion 11 extending from the opposed portion 10t, a portion at the side corresponding to the inlet port 101 may have the same outer diameter Rt as the opposed portion 10t, and the gradually decreasing diameter structure 11a having the gradually changing outer diameter m that decreases gradually may be provided next to the above portion. That is, the gradually decreasing diameter structure 11a may be formed in at least a portion of the extension portion 11.

**[0069]** In the present embodiment, the outer diameter Rs of the lower end (the end closer to the outlet port 133) of the extension portion 11 is equal in value to the gradually changing outer diameter m of the lowest end (the end closer to the outlet port 133) of the gradually decreasing diameter structure 11a. However, the present invention is not limited to this. That is, the value of the

gradually changing outer diameter m of the lowest end of the gradually decreasing diameter structure 11a may be equal to the value of the inner diameter r of the opposed portion 10t.

**[0070]** The extension portion 11 functions to reduce the stress applied to the lower end portion of the cylindrical portion 102d. In terms of stress reduction, providing the reduced diameter portion 50 and the gradually decreasing diameter structure 11a further reduces the stress.

**[0071]** For this reason, within the bounds of dimensional restrictions, the extension portion 11 is provided that is formed by the reduced diameter portion 50 and the gradually decreasing diameter structure 11a.

**[0072]** FIGS. 8A and 8B are diagrams showing forms of connection between the reduced diameter portion 50 and the gradually decreasing diameter structure 11a.

**[0073]** Since stress tends to concentrate at the section where the gradually decreasing diameter structure 11a is connected to the reduced diameter portion 50, this section preferably has a structure that reduces the likelihood of stress concentration.

**[0074]** In FIG. 8A, a tapered structure X is adopted as the gradually decreasing diameter structure 11a. In FIG. 8B, a rounded-corner shape Y is adopted as the gradually decreasing diameter structure 11a.

**[0075]** Other than the structures shown in FIGS. 8A and 8B, the present embodiment may use any structure that can reduce stress concentration.

**[0076]** In the present embodiment, the gradient of the gradually decreasing diameter structure 11a is linear as viewed in a cross-section, but the present invention is not limited to this. For example, although not shown, the gradient of the gradually decreasing diameter structure 11a may be curved as viewed in a cross-section.

**[0077]** The present embodiment having the above configuration can reduce the stress applied to the inner diameter side of the gradually decreasing diameter structure 11a, which accounts for the creep life of the cylindrical portion 102d, without lowering the rotation speed of the rotating body including the cylindrical portion 102d.

**[0078]** Moreover, since the prevention of creep is achieved without lowering the rotation speed, a reduction in the exhaust performance of the turbomolecular pump 100, which would otherwise occur due to a lowered rotation speed, is prevented.

**[0079]** Alternatively, this configuration allows the rotation speed of the rotor portion including the cylindrical portion 102d to be higher, thereby improving the exhaust performance of the turbomolecular pump 100.

**[0080]** The reduced diameter portion 50 described above has a uniform outer diameter Rs. However, the present invention is not limited to this, and the outer diameter Rs may decrease toward the lower end.

**[0081]** Although the reduced diameter portion 50 and the gradually decreasing diameter structure 11a have been described separately, they may be configured to be integral, or each of them may be configured as a grad-

ually decreasing diameter structure having an outer diameter that gradually changes toward the lower end.

**[0082]** The embodiments and modifications of the present invention may be combined as necessary.

**[0083]** Also, the invention is amenable to various modifications without departing from the spirit of the invention. The invention is, of course, intended to cover all modifications.

REFERENCE SIGNS LIST

**[0084]**

10t	Opposed portion	
11	Extension portion	15
11a	Gradually decreasing diameter structure	
50	Reduced diameter portion	
100	Turbomolecular pump	
101	Inlet port	
102	Rotor blade	20
102d	Cylindrical portion	
103	Rotating body	
113	Rotor shaft	
123	Stator blade	
125	Stator blade spacer	25
127	Outer cylinder	
129	Base portion	
131	Threaded spacer	
131a	Thread groove	
133	Outlet port	30
200	Controller	

**Claims**

1. A vacuum pump comprising:

a casing having an inlet port and an outlet port;  
a thread groove type exhaust mechanism that is fixed to the casing and includes a thread groove;  
a rotating shaft that is enclosed and rotationally supported by the casing; and  
a rotating cylinder disposed on the rotating shaft, the rotating cylinder including an opposed portion facing the thread groove type exhaust mechanism across a clearance and an extension portion extending to a further downstream side than the thread groove type exhaust mechanism, the extension portion including a reduced diameter portion having an outer diameter that is smaller than an outer diameter of the opposed portion and a gradually decreasing diameter structure configured to reduce stress concentration.

2. The vacuum pump according to claim 1, wherein the gradually decreasing diameter structure is a tapered

structure.

3. The vacuum pump according to claim 1, wherein the gradually decreasing diameter structure is a curved shape.

4. The vacuum pump according to any one of claims 1 to 3, wherein the gradually decreasing diameter structure is included in the reduced diameter portion.

5. A rotating cylinder of a vacuum pump, wherein the vacuum pump includes:

a casing having an inlet port and an outlet port;  
a thread groove type exhaust mechanism that is fixed to the casing and includes a thread groove; and a rotating shaft that is enclosed and rotationally supported by the casing,  
the rotating cylinder is disposed on the rotating shaft, the rotating cylinder comprises an opposed portion facing the thread groove type exhaust mechanism across a clearance and an extension portion extending to a further downstream side than the thread groove type exhaust mechanism, the extension portion including a reduced diameter portion having an outer diameter that is smaller than an outer diameter of the opposed portion and a gradually decreasing diameter structure configured to reduce stress concentration.



Fig. 1

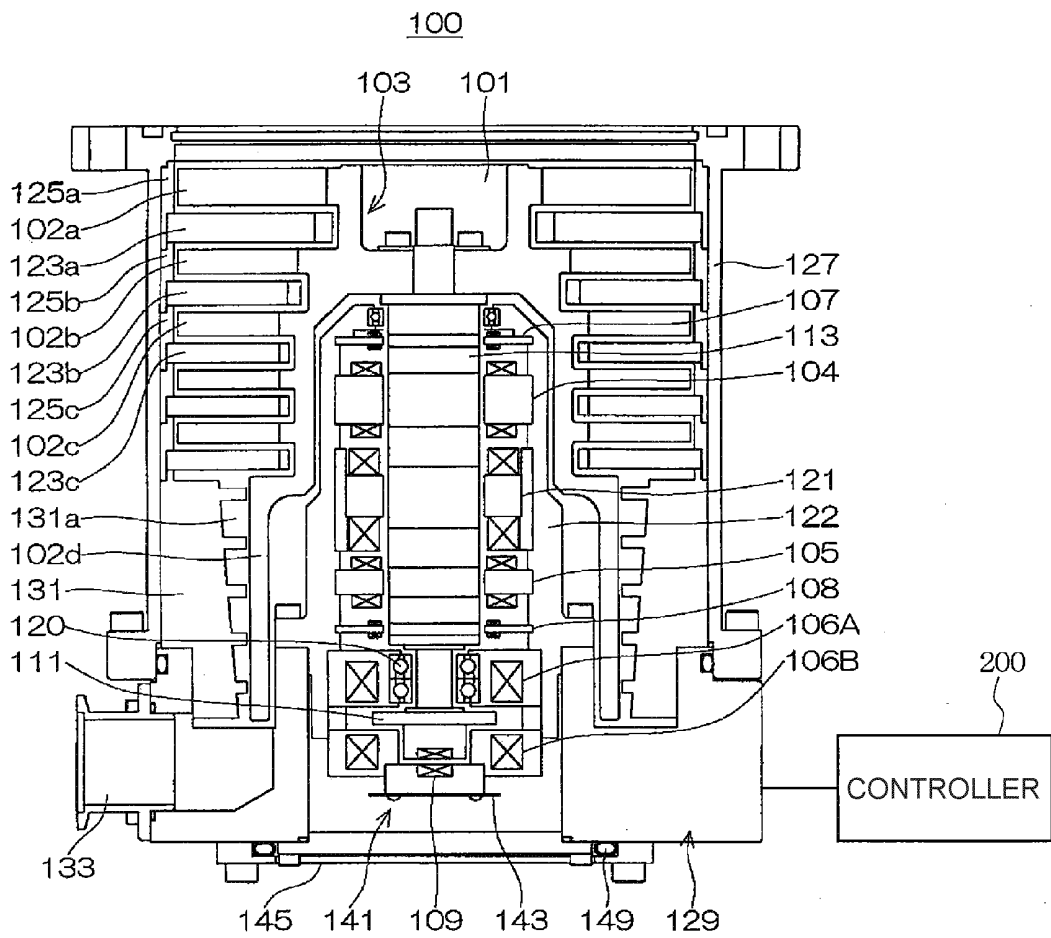


Fig. 2

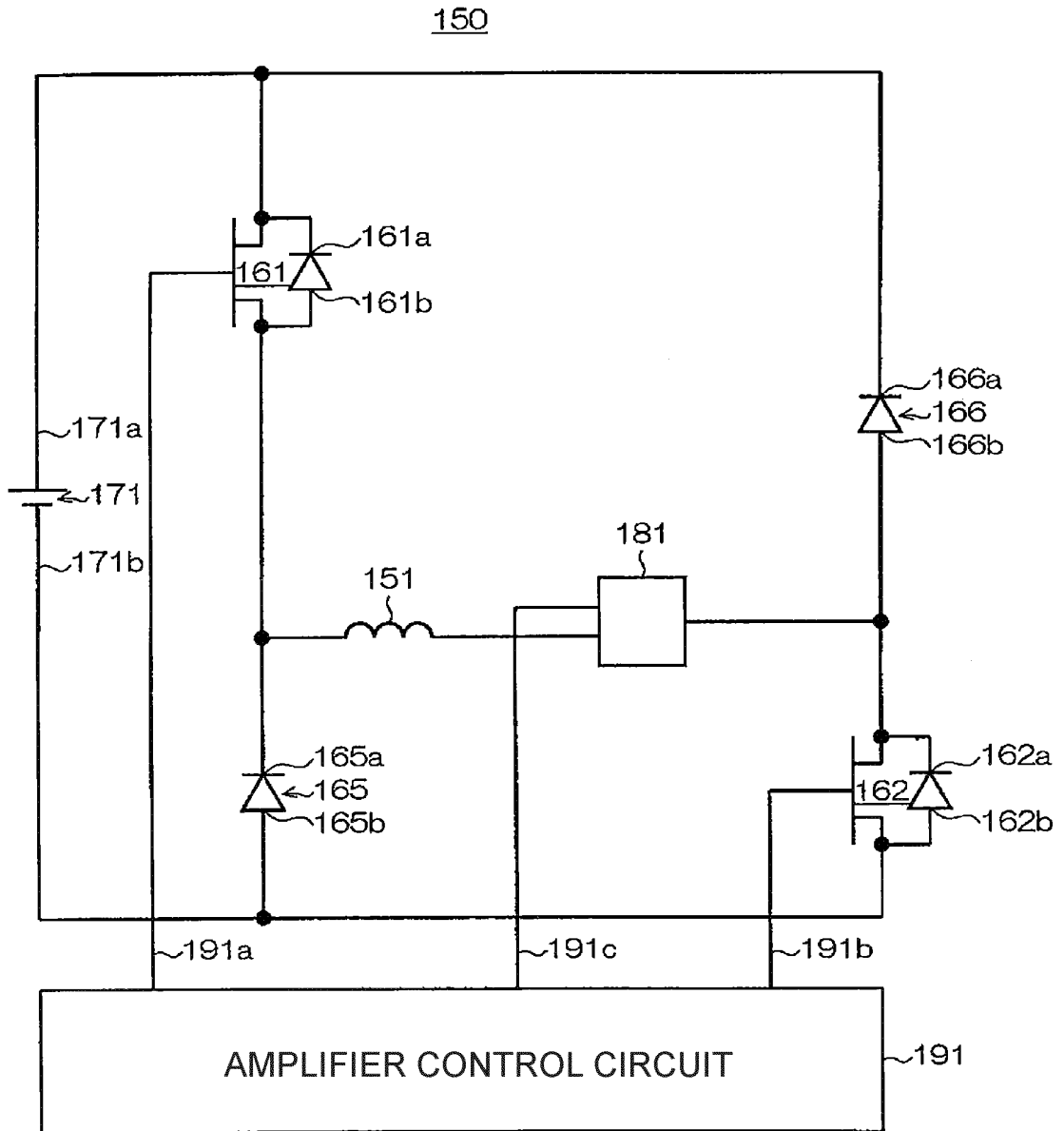


Fig. 3

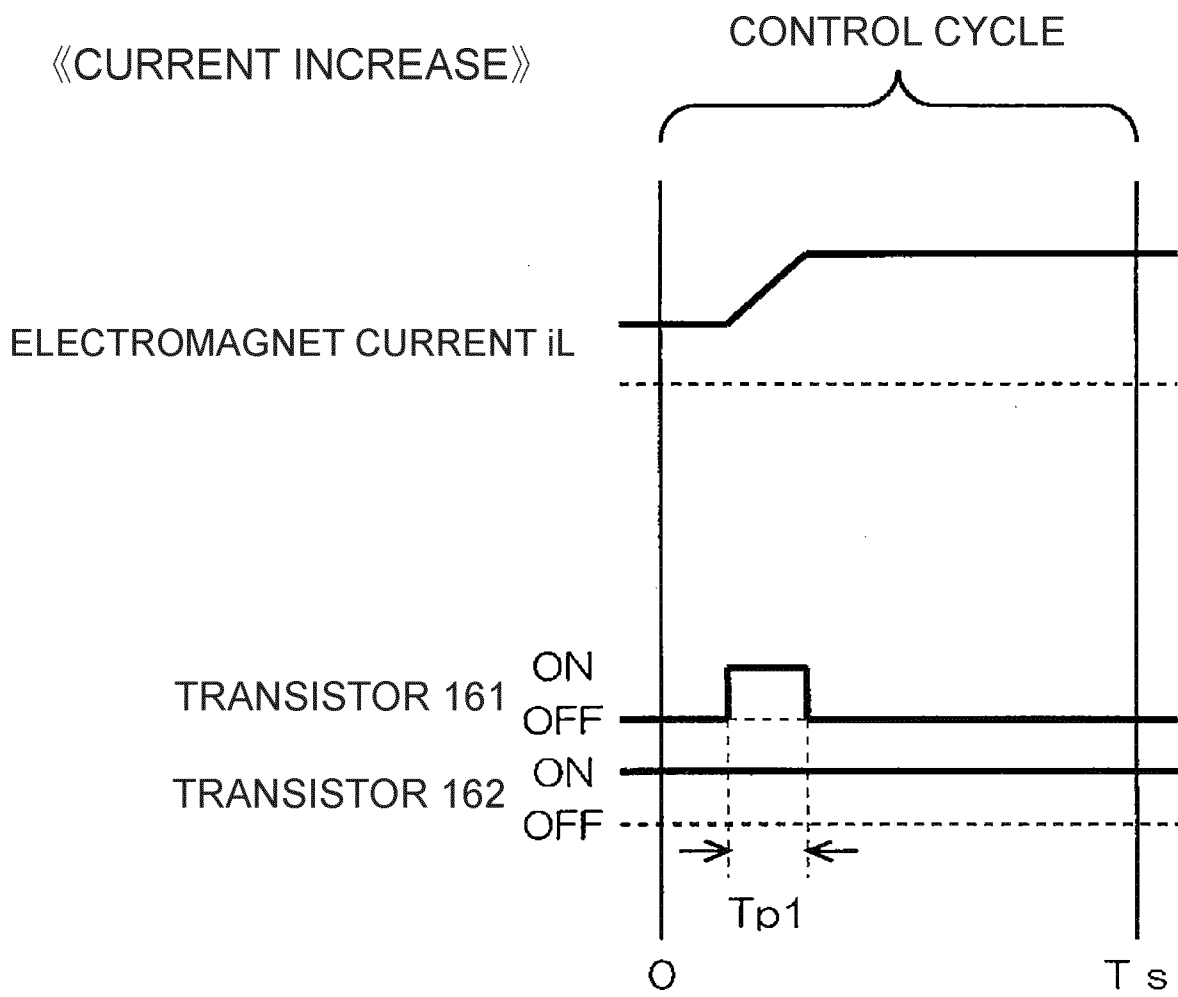


Fig. 4

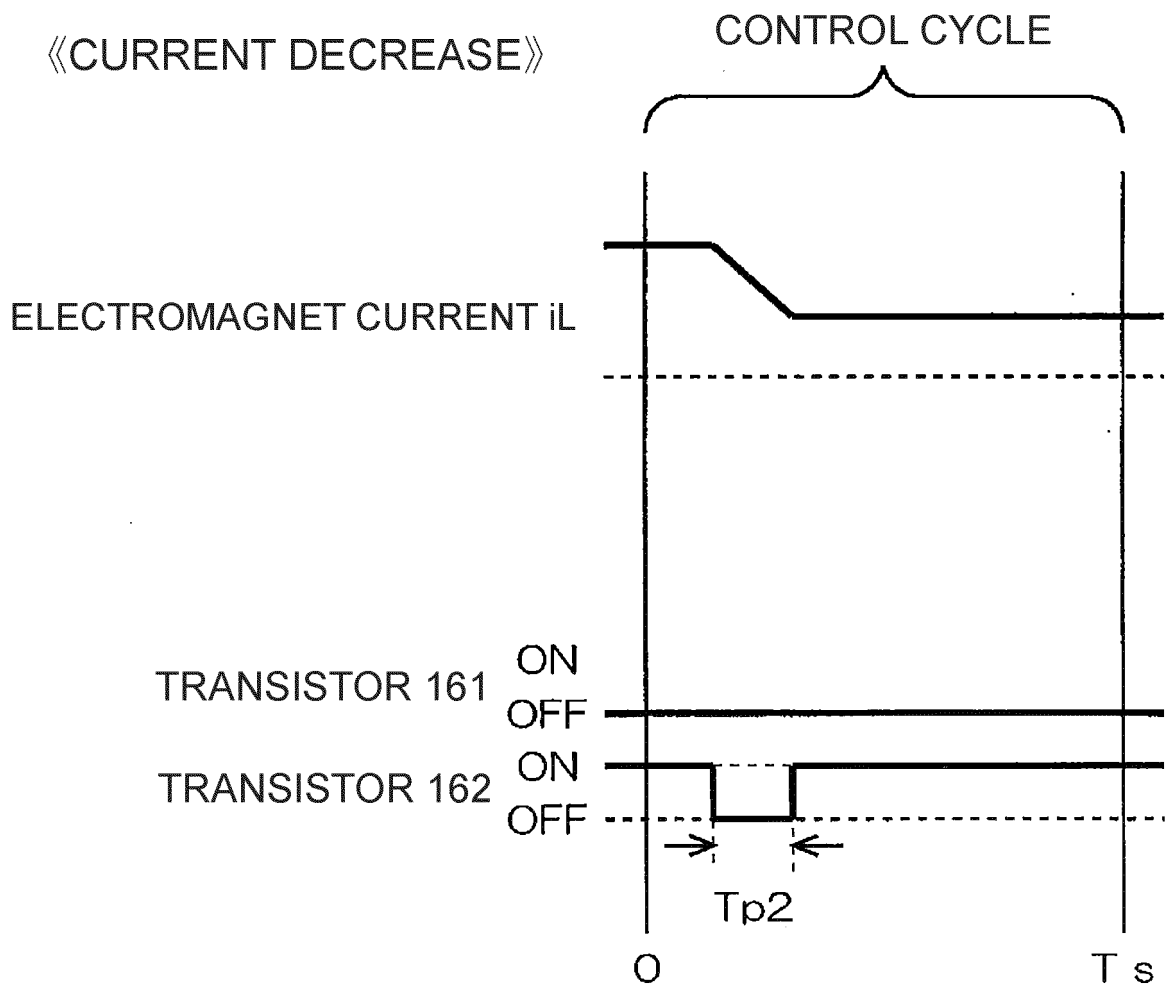


Fig. 5

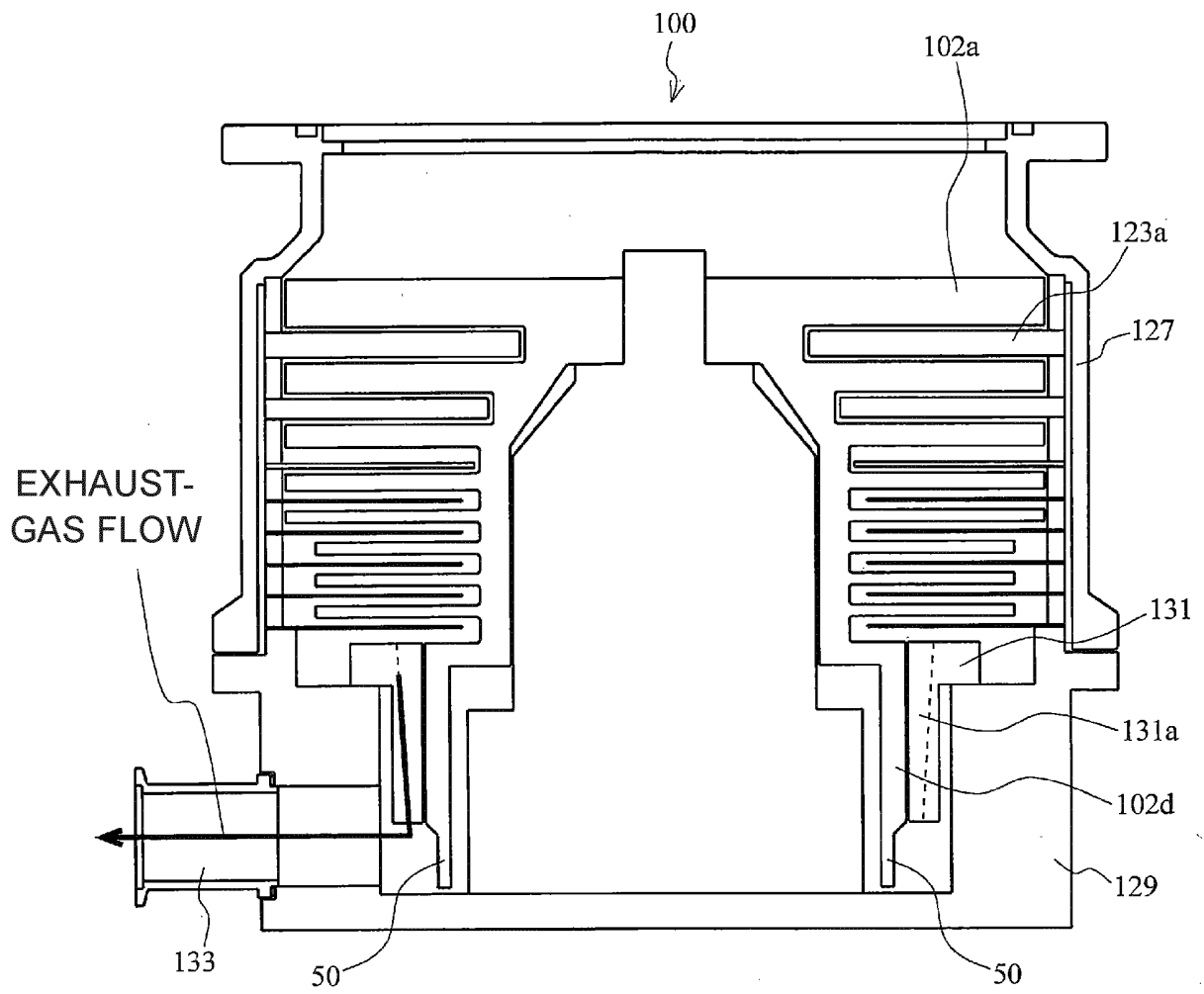


Fig. 6

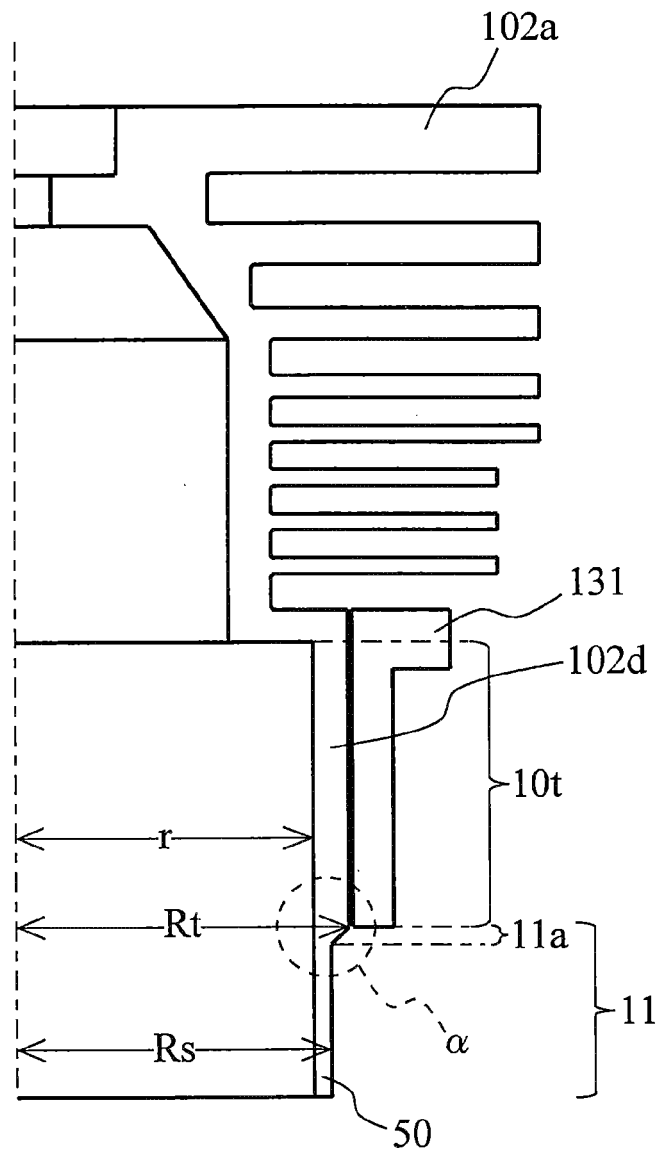


Fig. 7

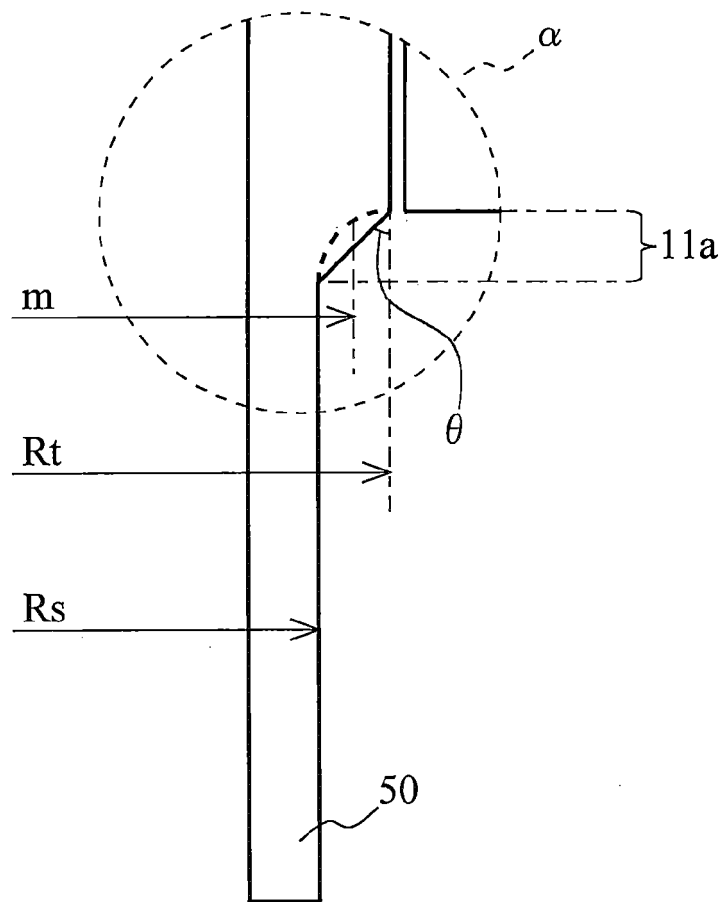


Fig. 8A

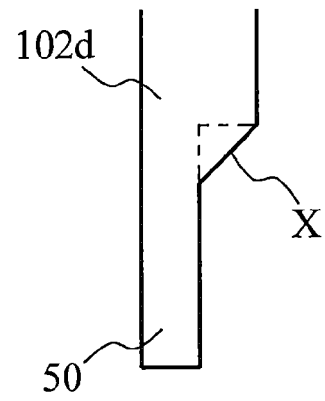


Fig. 8B

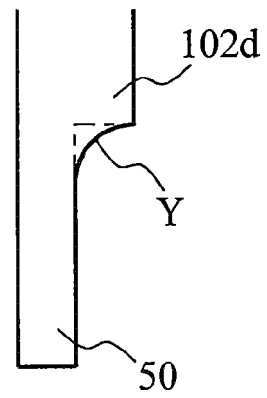
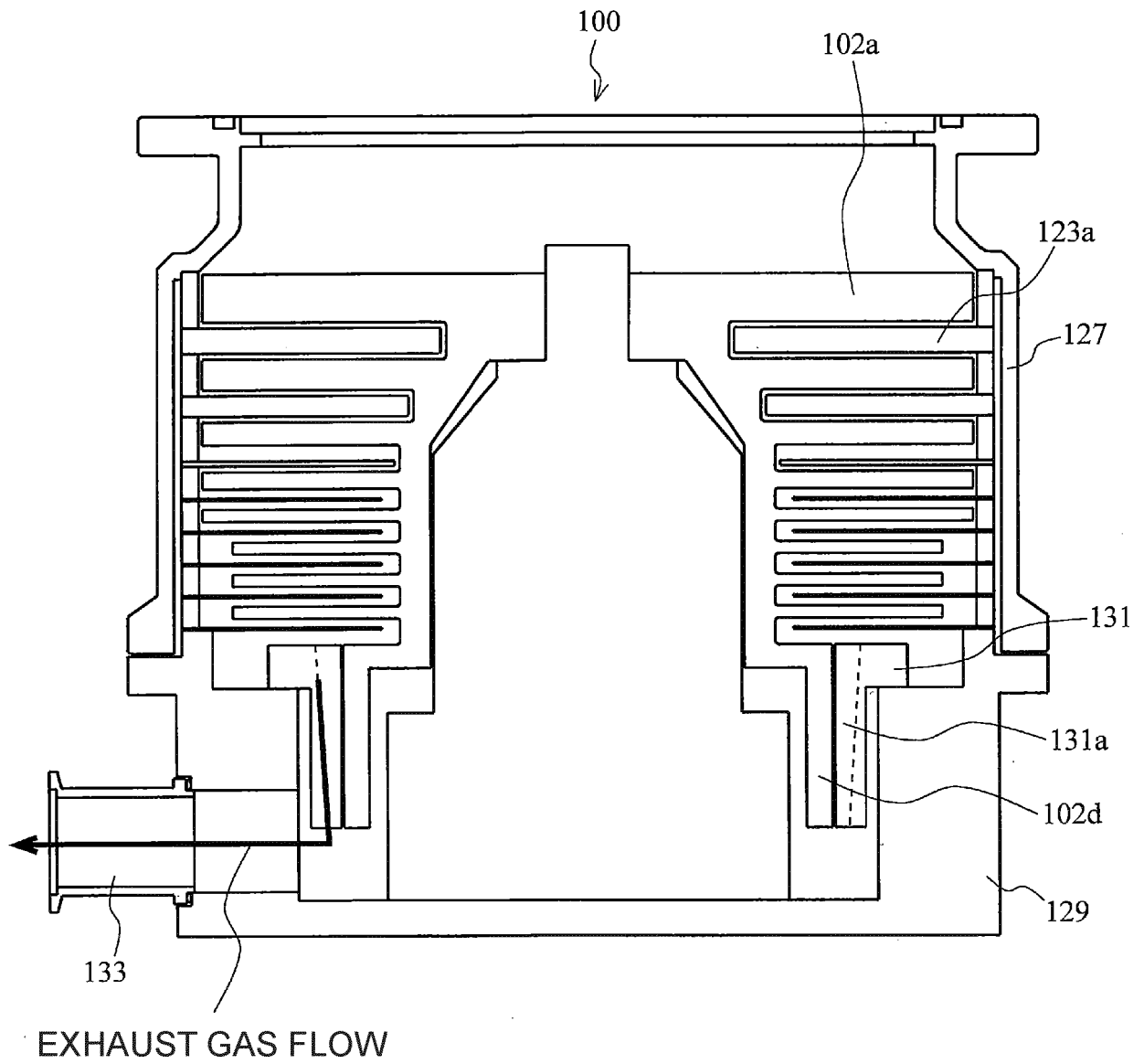




Fig. 9



## INTERNATIONAL SEARCH REPORT

International application No.

PCT/JP2021/036488

5	<b>A. CLASSIFICATION OF SUBJECT MATTER</b>	
	<b>F04D 19/04</b> (2006.01)i FI: F04D19/04 D; F04D19/04 E  According to International Patent Classification (IPC) or to both national classification and IPC	
10	<b>B. FIELDS SEARCHED</b>	
	Minimum documentation searched (classification system followed by classification symbols) F04D19/04  Documentation searched other than minimum documentation to the extent that such documents are included in the fields searched Published examined utility model applications of Japan 1922-1996 Published unexamined utility model applications of Japan 1971-2021 Registered utility model specifications of Japan 1996-2021 Published registered utility model applications of Japan 1994-2021	
15	Electronic data base consulted during the international search (name of data base and, where practicable, search terms used)	
20	<b>C. DOCUMENTS CONSIDERED TO BE RELEVANT</b>	
	Category*	Citation of document, with indication, where appropriate, of the relevant passages
		Relevant to claim No.
25	X	JP 2018-35718 A (EDWARDS KK) 08 March 2018 (2018-03-08) paragraphs [0017]-[0022], [0024], fig. 1-4
	A	WO 2012/077411 A1 (EDWARDS KK) 14 June 2012 (2012-06-14) fig. 4, 7-9
30	A	Microfilm of the specification and drawings annexed to the request of Japanese Utility Model Application No. 7647/1988 (Laid-open No. 113191/1989) (OSAKA VACUUM LTD.) 31 July 1989 (1989-07-31), fig. 2
35	<input type="checkbox"/> Further documents are listed in the continuation of Box C. <input checked="" type="checkbox"/> See patent family annex.	
40	* Special categories of cited documents: "A" document defining the general state of the art which is not considered to be of particular relevance "E" earlier application or patent but published on or after the international filing date "L" document which may throw doubts on priority claim(s) or which is cited to establish the publication date of another citation or other special reason (as specified) "O" document referring to an oral disclosure, use, exhibition or other means "P" document published prior to the international filing date but later than the priority date claimed	"T" later document published after the international filing date or priority date and not in conflict with the application but cited to understand the principle or theory underlying the invention "X" document of particular relevance; the claimed invention cannot be considered novel or cannot be considered to involve an inventive step when the document is taken alone "Y" document of particular relevance; the claimed invention cannot be considered to involve an inventive step when the document is combined with one or more other such documents, such combination being obvious to a person skilled in the art "&" document member of the same patent family
45	Date of the actual completion of the international search	Date of mailing of the international search report
	<b>26 November 2021</b>	<b>14 December 2021</b>
50	Name and mailing address of the ISA/JP	Authorized officer
	<b>Japan Patent Office (ISA/JP)</b> <b>3-4-3 Kasumigaseki, Chiyoda-ku, Tokyo 100-8915</b> <b>Japan</b>	Telephone No.
55	Form PCT/ISA/210 (second sheet) (January 2015)	

INTERNATIONAL SEARCH REPORT  
Information on patent family members

International application No.  
**PCT/JP2021/036488**

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Patent document cited in search report	Publication date (day/month/year)	Patent family member(s)	Publication date (day/month/year)
JP 2018-35718 A	08 March 2018	US 2019/0195238 A1 paragraphs [0054]-[0069], [0079], fig. 1-4	
		WO 2018/043072 A1	
		EP 3524821 A1	
		CN 109563841 A	
		KR 10-2019-0040131 A	
WO 2012/077411 A1	14 June 2012	US 2013/0243583 A1 fig. 4, 7-9	
		EP 2650544 A1	
JP 1-113191 U1	31 July 1989	(Family: none)	

**REFERENCES CITED IN THE DESCRIPTION**

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**Patent documents cited in the description**

- JP H10246197 B [0007]